



**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2624
PATENT**

Attorney Docket No. 02887.0251-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Tadashi MITSUI)	
)	Group Art Unit: 2624
Application No.: 10/670,387)	
)	Examiner: Desire, Gregory M.
Filed: September 26, 2003)	
)	
For: PATTERN MEASUREMENT)	Confirmation No.: 2738
METHOD, MANUFACTURING)	
METHOD OF SEMICONDUCTOR)	Mail Stop AF
DEVICE, PATTERN)	
MEASUREMENT APPARATUS,)	
AND PROGRAM)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION

In reply to the Final Office Action mailed May 18, 2006, the period for response to which extends through August 18, 2006, and pursuant to 37 C.F.R. § 1.116, Applicant requests the Examiner's reconsideration in view of the remarks that follow:

Remarks/Arguments begin on page 2 of this paper.